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IN THE US PATENT AND TRADEMARK OFFICE

Re: Application of
Fontana, Jr. et al.

Art Unit: 1756

Application No: 09/853,345

Examiner: McPherson, John A.

Filed: 05/10/2001

Confirmation number: 7852

Docket number: ARC9-2001-0017US1

For: Fully Undercut Resist Systems Using E-Beam Lithography for
the Fabrication of High Resolution MR Sensors

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Applicant replies to the Office Action mailed 5/21/2004 as
follows:

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(IBM-156/US) Reply 3